

AF/Jan

MS AF  
REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP

## AMENDMENT TRANSMITTAL LETTER

Docket No.  
3313-1048P

Application No.  
10/690,503-Conf. #006047

Filing Date  
October 23, 2003

Examiner  
C. F. F. Lam

Art Unit  
1775

Applicant(s): I-Cherng CHEN et al.

Invention: MATERIAL WITH SURFACE NANOMETER FUNCTIONAL STRUCTURE AND METHOD  
OF, etc.

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

### CLAIMS AS AMENDED

	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	18	- 37 =		x	
Independent Claims	2	- 4 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

☒ Large Entity

☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.

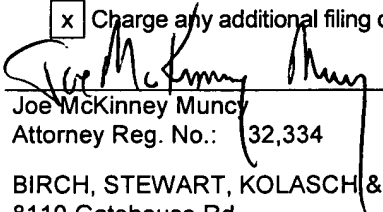
☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

☒ The Director is hereby authorized to charge and credit Deposit Account No. 02-2448  
as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
Joe McKinney Muncy  
Attorney Reg. No.: 32,334

Dated: May 16, 2005

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**MS AF  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1775**

PATENT  
3313-1048P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: CHEN, I-Cherng et al. Conf.:6047  
Appl. No.: 10/690,503 Group: 1775  
Filed: October 23, 2003 Examiner: Cathy F.F. LAM  
For: MATERIAL WITH SURFACE NANOMETER FUNCTIONAL  
STRUCTURE AND METHOD OF MANUFACTURING THE  
SAME

**REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116**

**MS AF**

Commissioner for Patents  
P.O. BOX 1450  
Alexandria, VA 22313-1450

May 16, 2005

Sir:

In response to the Examiner's Office Action dated February 14, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amendments to the Specification;

Amended Claim set; and

Remarks.